

TITLE: WAFER-LEVEL TESTING
APPARATUS AND METHOD

Inventor: Farnworth et al.

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REPLACEMENT SHEET

3/7



Approved
to replace
M.T.

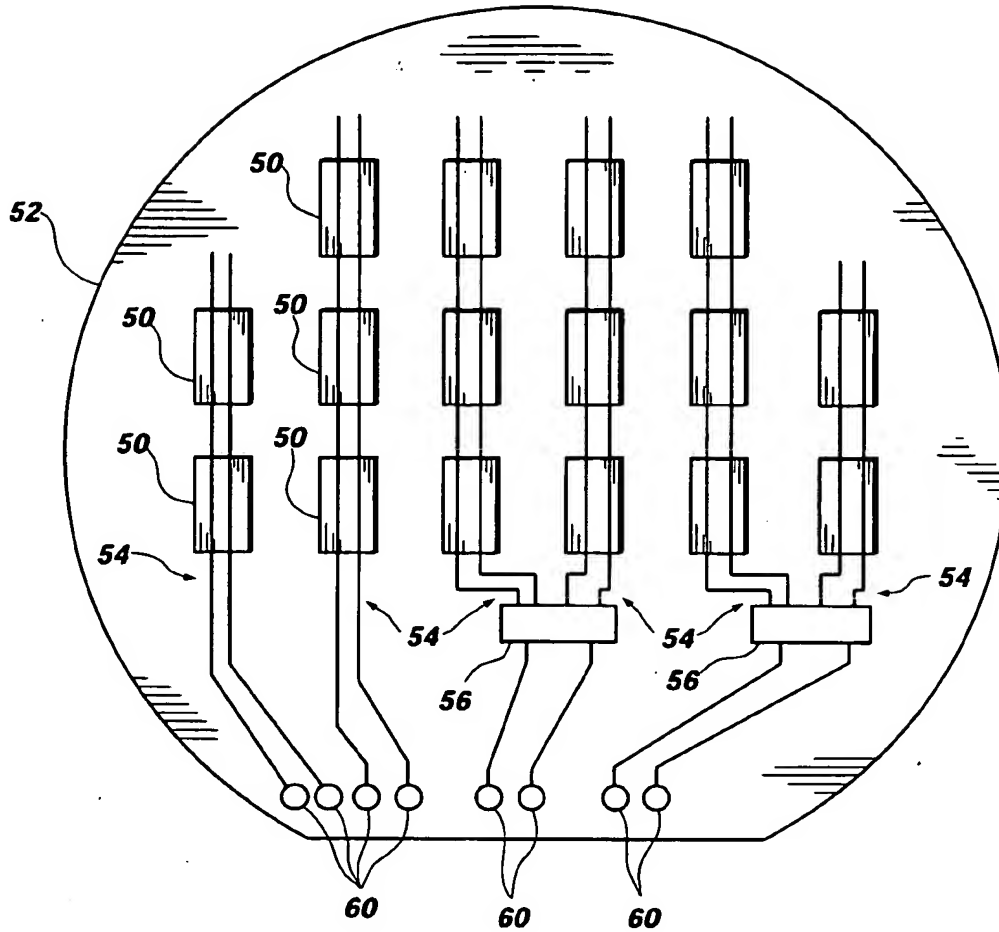


FIG. 3

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